



PATENT APPLICATION *1K*
AP

IN THE U.S. PATENT AND TRADEMARK OFFICE

May 14, 2008

Applicants : Yoshio KAJIYA et al
For : METHOD OF PRODUCING CATHODE MATERIAL FOR
LITHIUM SECONDARY CELL
Serial No. : 10/521 370 Group: 1795
Confirmation No.: 2268
Filed : January 12, 2005 Examiner: Echelmeyer
International Application No.: PCT/JP2003/002027
International Filing Date : February 25, 2003
Atty. Docket No.: 4402.P0666US

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**NOTICE OF APPEAL FROM THE PRIMARY EXAMINER
TO THE BOARD OF APPEALS**

Sir:

Applicant hereby appeals to the Board of Appeals from the decision mailed November 14, 2007 of the Primary Examiner finally rejecting Claims 1-8.

(Please see following page.)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on May 14, 2008.

Respectfully submitted,



Terryence F. Chapman

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The item(s) checked below are appropriate:

☒ A Petition and fee for extension accompany this Notice.

☒ Appeal fee:

☒ \$510.00 (large entity).

☐ \$255.00 (small entity).

Statement(s) re small entity status:

☐ Attached.

☐ Previously filed.

☒ A check for \$1,560.00 is enclosed to cover fees.

☐ Please charge the Appeal Fee of \$_____ to Deposit Account 06-1382. A duplicate copy of this sheet is enclosed.

☒ The Commissioner is hereby authorized to charge any additional fees required by this paper or to credit any overpayment to Deposit Account No. 06-1382. A duplicate copy of this sheet is enclosed.

☒ An acknowledgement Postal Card is enclosed.

Respectfully submitted,

IN DUPLICATE


Terryence F. Chapman

TFC/smd

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Reg. No. 43 977
Reg. No. 57 391
Reg. No. 24 323
Reg. No. 24 949
Reg. No. L0379*

Encl: Listed Above

150.09/07